

# Plasma Germany

## Fachausschuss Normung

### *Bericht Herbstsitzung 2010, Aachen*

- **DIN NA 062-08-16 AA**  
*(Spiegelausschuss ISO/TC 201)*
- **DIN NA 062-08-17 AA**  
*(Spiegelausschuss ISO/TC 229 + CEN/TC 352)*

DIN NA 062 Normenausschuss Materialprüfung (NMP)

**DIN NA 062-08-16 AA**

**Arbeitsausschuss Chemische Oberflächenanalyse und  
Rastersondenmikroskopie**

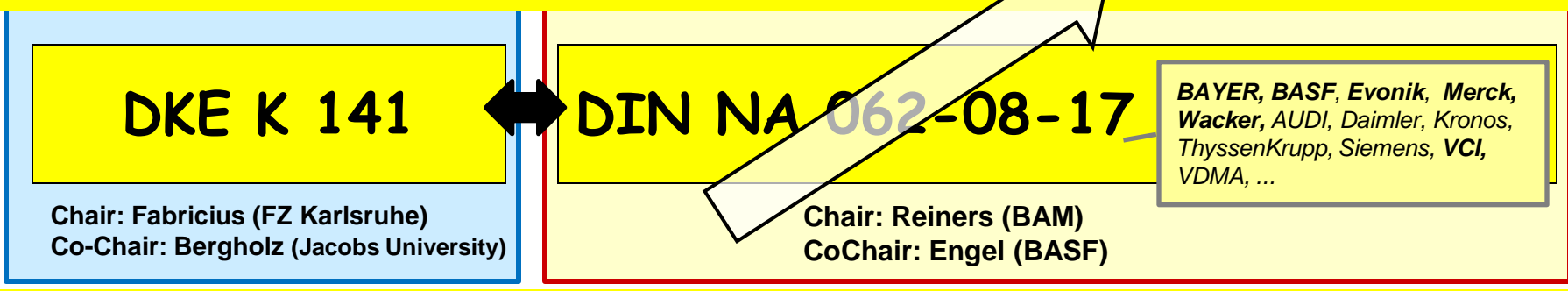
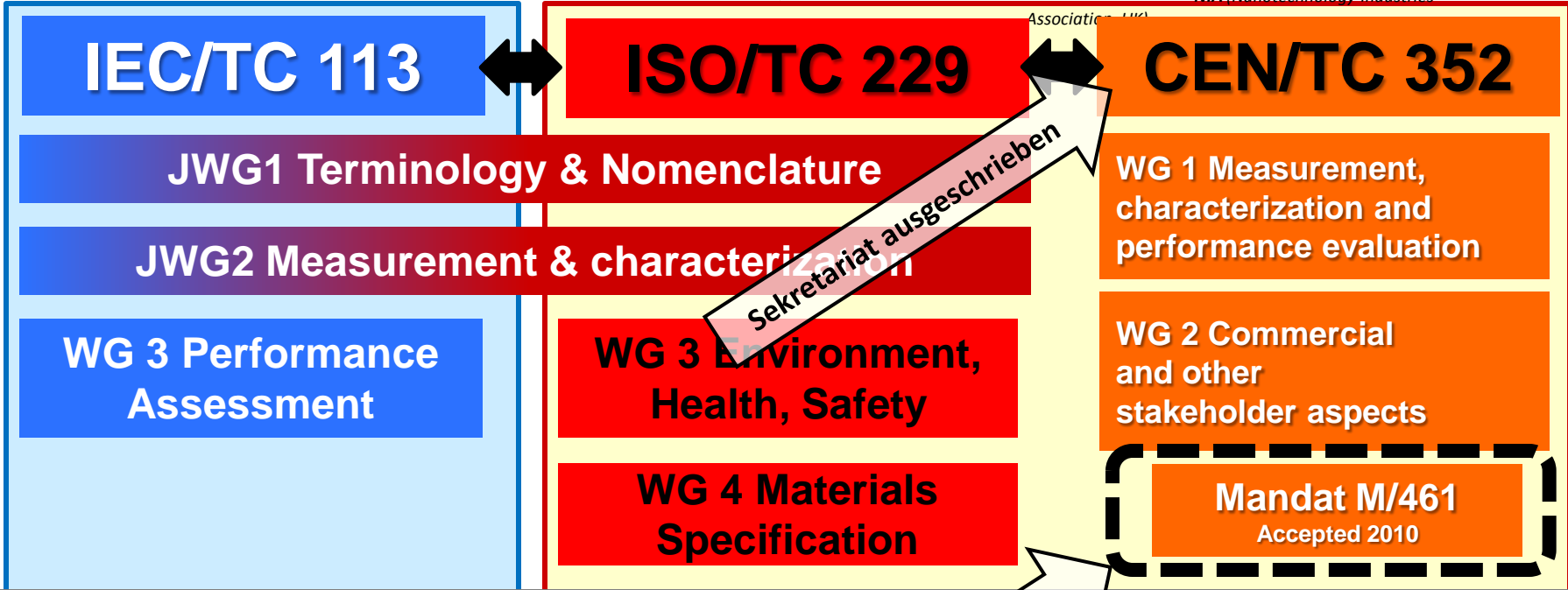
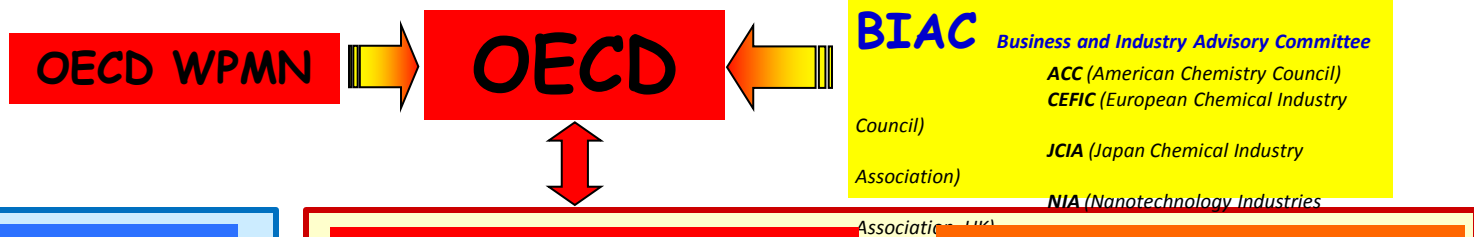
***Spiegelausschuß für ISO/TC 201***

Referent im DIN: Dr.-Ing. Michael Schmitt

Obmann: Dr. Vasile-Dan Hodoroaba (BAM VI.4)

**1. Sitzung am 21. Juni 2010 in Berlin  
(bereits 1995 – 1997 als NMP 816 in Funktion)**

*international*



## Mandate addressed to CEN, CENELEC + ETSI for Standardization Activities regarding Nanotechnologies and Nanomaterials

**in cooperation with**

- **ISO/TC 229**
- **OECD**



EUROPEAN COMMISSION  
ENTERPRISE AND INDUSTRY DIRECTORATE-GENERAL

MANDATE ADDRESSED TO CEN, CENELEC AND ETSI FOR  
STANDARDIZATION ACTIVITIES REGARDING NANOTECHNOLOGIES  
AND NANOMATERIALS

## Characterisation and exposure assessment of nanomaterials

1. Methodologies for nanomaterial characterization in the manufactured form and before toxicity and eco-toxicity testing
2. Sampling and measurement of workplace, consumer and environment exposure to nanomaterials
3. Methods to simulate exposures to nanomaterials

**Vielen Dank für Ihre Aufmerksamkeit**



Quelle: [www.begann.de/](http://www.begann.de/)